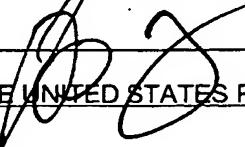




Docket No.: P2001,0678

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

By:  Date: April 15, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/813,530
Applicant : Volker Härtle, et al.
Filed : March 29, 2004
Title : Method for Fabricating a Semiconductor Component Based on a Nitride Compound Semiconductor
Docket No. : P2001,0678
Customer No. : 24131

L E T T E R

Mail Stop: Missing Parts
Hon. Commissioner for Patents,
Alexandria, VA 22313-1450

Sir:

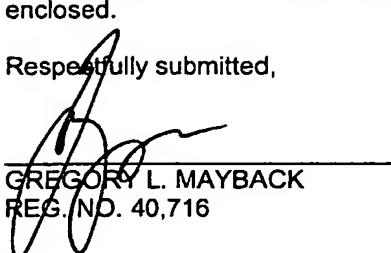
The above-mentioned new patent application was filed on March 29, 2004 without a signed oath or declaration, under the provision of 37 C.F.R. 1.53(f).

In accordance with the above-mentioned rule, enclosed herewith is the original signed declaration.

The undersigned hereby states that the application filed in the Patent and Trademark Office is the application which the inventor(s) executed by signing the declaration. MPEP 602 (8th ed., Aug. 2001).

The fee required for the late filing of an oath or declaration in the amount of \$130.00 is also enclosed.

Respectfully submitted,



GREGORY L. MAYBACK
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/av

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